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Jacqueline J. Gamer

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JAN 0 7 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.:

09/921,364

Confirmation No.

6223

Applicant:

Lucius M. Sherwin

TC/A.U.:

2877

Filed:

8/2/2001

Examiner:

Khaled Brown

Docket No.: TI-30661

Customer No.:

23494

Title: A PARTICLE DETECTION AND REMOVAL APPRATUS FOR USE ON WAFER FABRICATION EQUIPMENT TO LOWER TOOL RELATED DEFECTS FROM

PARTICLE CONTAMINATION

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 703-872-9306 on the date shown below:

acquetine J. Garner, Reg. No. 36,144

January 7, 2004

FACSIMILE COVER SHEET

X FACSIMILE COME NEW APPLICADE DECLARATION ASSIGNMENT FORMAL DRAWN INFORMAL DRAWN CONTINUATION DIVISIONAL A	ITION N (# Pages) (# Pages) WINGS AWINGS IN APP'N (# Pages)	X AMENDMENT (10 Pages) X EOT 3mth (3 Pages) NOTICE OF APPEAL (# Pages) APPEAL (# Pages) ISSUE FEE (# Pages) REPLY BRIEF (IN TRIPLICATE) (# Pages) X Fee sheet (3 pages)		
NAME OF INVENTOR(S):		RECEIPT DATE & SERIAL NO.:		
Sherwin TITLE OF INVENTION:		Serial No.: 09/921,364 Filing Date: 08/02/2001		
A Particle Detection ar	d Removal			
TI FILE NO.:	DEPOSIT ACCT. NO.:	Conf. No.: 6223		
TI-30661	20-0668			
FAXED: 1/7/2004 DUE: 11/01/2003 ATTY/SEC'Y: JJG				

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> Texas Instruments Incorporated PO Box 655474, M/S 3999 Dallas, TX 75074

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p.2

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Amendment Fee

Assistant Commissioner of Patents P. O. Box 1450 Alexandria, VA 22313-1450 January 7, 2004

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 703-872-9306 on the date

shown below:

Dear Sir:

Jacqueline J. Garner, Reg. No. 36,144

January 7, 2004

Date

Transmitted herewith is an amendment in the above-identified Application. The Fee has been calculated as shown below.

CLAIMS AS AMENDED								
	Claims remaining after amendment		Highest Number Previously Paid for	Present Extra	Rate	Additional Fee		
TOTAL	19	Minus	20	= 0	x \$18	\$ 00.00		
Independent Claims	5	Minus	3	= 2	x \$86	\$ 172.00		
Total Additional Fee for this Amendment						\$ 172.00		

Charge the total additional fee, and any further fees, or credit any overpayment to Deposit Account No. 20-0668. Three copies of this sheet are enclosed.

Texas Instruments Incorporated P. O. Box 655474, MS 3999 Dallas, Texas 75265

Respectfully Submitted.

Jaøquetine J. Gamer Æeg. No. 36,144